



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Marie D'Angelo, et al. CONFIRMATION NO.: 5196
SERIAL NO.: 10/520,647
FILING DATE: January 5, 2005
TITLE: Metallic Nano-Objects Formed On Semiconductor Surfaces And
Manufacturing Process For These Nano-Objects
EXAMINER: Chiu, Tsz K..
ART UNIT: 2822

CERTIFICATE OF MAILING

I hereby certify that this paper is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria VA 22313-1450, on the date printed below:

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AMENDMENT AND RESPONSE TO OFFICE ACTION

Sir:

This paper is responsive to the Office Action of October 9, 2007. Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begin on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.

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